

ATTORNEY DOCKET NO.
TI-35029 (032350.B541)

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Antonio L.P. Rotondaro
Serial No.: Unassigned
Filing Date: December 15, 2003
Title: *Method Of Fabricating A Dielectric Layer For
 A Semiconductor Structure*

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicant respectfully requests, pursuant to 37 C.F.R. §§1.56, 1.97, and 1.98, that the document listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. Furthermore, pursuant to 37 C.F.R. §§1.97(g) and (h), Applicant makes no representation that this document qualifies as prior art or that this document is material to patentability of the present application or that a search has been made.

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PATENT APPLICATION

Since the present Application was filed after June 30, 2003, a copy of any U.S. Patent and any U.S. Patent Application Publication cited on the attached PTO Form 1449 is not being submitted with this Information Disclosure Statement pursuant to the July 11, 2003 waiver of 37 C.F.R. S 1.98(a)(2)(i) by the U.S. Patent and Trademark Office.

Respectfully submitted,

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Date: December 15, 2003

Customer Number: **23494**

Patent Trademark Office

PTO-1449				Application No. Unknown		Applicant(s) Antonio L.P. Rotondaro	
Information Disclosure Citation In an Application				Docket Number TI-35029 (032350.B541)		Group Art Unit Unknown	
						Filing Date December 15, 2003	
U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A	2003/0109146 A1	06/12/2003	Luigi, et al.	438	769	01/31/2002
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						
	M						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES NO
	N						
	O						
	P						
	Q						
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
	R						
	S						
	T						
EXAMINER				DATE CONSIDERED			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

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